


<b>Search Notes</b>  	<b>Application/Control No.</b>  10790213	<b>Applicant(s)/Patent Under Reexamination</b>  TABATA, SEIICHIRO
	<b>Examiner</b>  Liu, Li	<b>Art Unit</b>  2613

SEARCHED			
Class	Subclass	Date	Examiner
398	42, 135-139,	11/13-11/17, 2006	LL
385	31-37, 92, 93, 14	11/13-11/17, 2006	LL
359	569, 565	11/13-11/17, 2006	LL
369	112	11/13-11/17, 2006	LL

SEARCH NOTES		
Search Notes	Date	Examiner
EAST: US-PGPUB, USPAT, EPO, JPO, DERWENT, IBM_TDB	11/13-11/17, 2006, 6/4/2007	LL
GOOGLE	11/13-11/17, 2006	LL
IEEE	11/13-11/17, 2006	LL
INSPECT, OpticsInfoBase, SPIE Digital Library	11/13-11/17, 2006	LL

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner